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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT

FIRST NAMED INVENTOR

Mitsutoshi HIGASHI

(Use several sheets if necessary)

Mitsutosni Higas

FILING DATE

November 14, 2003

GROUP ART UNIT
28 13

U.S. PATENT DOCUMENTS

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EXAMINER INITIAL		DOCUMENT NO.	DATE		NAME	CLASS	SUB- CLASS	FILING DATE
LL	AA	2002/00018 73 A1	01/2002	Kang				
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	AC							
	AD							
	AE	,						
	AF		-					

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Le	AG	8-184608	07/1996	Japan			abs	
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	AJ							
	AK							
	AL						·	

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

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EXAMINER			DATE CONSIDERED 2/27/06
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EXAMINER: In	tial if reference considered, whele	er or not citation is in cont	formance with MPEP 609; Draw line through citation if not in conformance
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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE

ATTORNEY DOCKET NO.

Sheet 1 of 1 APPLICATION NO.

PATENT AND TRADEMARK OFFICE

300.1138 FIRST NAMED INVENTOR 10/706,912

INFORMATION DISCLOSURE STATEMENT

Mitsutoshi HIGASHI

FILING DATE

GROUP ART UNIT

(Use several sheets if necessary)

November 14, 2003

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*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
Sh	AA	6,214,644	04/10/01	GLENN			
1	AB	5,610,431	03/11/97	MARTIN			
	AC	6,316,840	11/13/01	OTANI			
DL	AD	5,895,233	04/20/99	HIGASHI et al.			
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	AF						
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	l	DOCUMENT	1			1	•••

			FUREIGINF	AIENT DOCUMENTS		
		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
Xh	AG	99/67818	12/29/99	WIPO		X : "
Xl	AH	02/055431	07/18/02	WIPO		X
× _	Al					
	AJ					

OTHER RE	FERE	NCES (Including Author, Title, Date, Pertinent Pages, Etc.)	TRANSL YES	ATION NO .
Lle	AK	G. A. Riley, "Stud Bump Flip Chip Assembly of MEMS and MOEMS," Proceedings of the SPIE, International Symposium on Microelectronics, October 2001, vol. 4587, pp. 662-665.		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,
	AL	H. Park et al., "Packaging of the RF-MEMS Switch," Design Characterization, and Packaging for MEMS and Microelectronics II, December 2001, Proceedings of SPIE, vol. 4593, pp. 234-243.		
Du	AM .	J. Kim et al., "Ultrasonic Bonding of In/Au and Al/Al for Hermetic Sealing of MEMS Packaging," MEMS 2002, IEEE International Micro Electro Mechanical Systems Conference, Proceedings of the IEEE, January 2002, pp. 415-418.		

EXAMINER	DATE CONSIDERED
hauera Schels	2/27/06
*EXAMINER: Initial if reference considered, whether or not cita	ation is in conformance with MPEP 609. Draw line through

citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Revised January, 2005



ATTACHMENT 1(g)

TIST OF ADDITIONAL SUBWILLED	ST NAMED INV
M	tsutoshi H

ATTORNEY DOCKET NO.	APPLICATION NO.
300.1138	10/706,912
FIRST NAMED INVENTOR	
Mitsutoshi HIGASHI	
FILING DATE	GROUP ART UNIT
November 14, 2003	

The following document(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application.

It is requested that the Examiner acknowledge his consideration of document(s) below-listed by initialling same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application; and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSL YES	ATION NO
AC							
AD							:•;

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
	AE	Partial European Search Report dated May 9, 2005 of Application No. EP 03 25 7126.		

EXAMINER	DATE CONSIDERED

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Sheet 1 of 1 ATTORNEY DOCKET NO. U.S. DEPARTMENT OF COMMERCE **FORM PTO-1449** PATENT AND TRADEMARK OFFICE 10/706,912 300.1138 FIRST NAMED INVENTOR P INFORMATION DISCLOSURE STATEMENT Mitsutoshi HIGASHI FILING DATE **GROUP ART UNIT** (Use several sheets if necessary) November 14, 2003 2813 **U.S. PATENT DOCUMENTS** FILING DOCUMENT SUB-CLASS DATE NO. CLASS DATE NAME 5.895.233 04/20/99 HIGASHI et al. AB 6,316,840 11/13/01 **OTANI** AC 5,610,431 03/11/97 MARTIN AD 6,214,644 GLENN 04/10/01 ΑE 05/07/02 PETERSON et al. 6,384,473 AF 10/31/00 NAJAFI et al. 6,140,144 FOREIGN PATENT DOCUMENTS DOCUMENT ABSTRACT NO. **TRANSLATION** DATE COUNTRY YES NO **WIPO** AG 02/01633 01/03/02 **WIPO** 99/67818 12/29/99 AH **WIPO** 02/055431 07/18/02 TRANSLATION OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.) YES NO G. A. Riley et al., "Stud Bump Flip Chip Assembly of MEMS and AJ MOEMS," Proceedings of the SPIE, International Symposium on Microelectronics, vol. 4587, Oct. 2001, pp. 662-665. K. Jongbaeg et al., "Ultrasonic Bonding of In/Au and Aval for Hermetic Sealing of MEMS Packaging," IEEE International Micro Electro ΑK Mechanical Systems Conference, Proceedings of the IEEE, January 2002, pp. 415-418. M. Heschel, "Stacking Technology for a Space Constrained Microsystem," Micro Electro Mechanical Systems, 1998, MEMS 98, Proceedings, IEEE, AL January 1998, pp. 312-317. H. Park et al., "Packaging of the RF-MEMS Switch," Design, ΑM Characterization and Packaging for MEMS and Microelectronics II, Proceedings of the SPIE, vol. 4593, December 2001, pp. 234-243. DATE CONSIDERED **EXAMINER** *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through

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ATTORNEY DOCKET NO.	APPLICATION NO.		
300.1138	10/706,912		
FIRST NAMED INVENTOR			
Mitsutoshi HIGASHI			
FILING DATE	GROUP ART UNIT		
November 14, 2003	2813		
	300.1138 FIRST NAMED INVENTOR Mitsutoshi HIGASHI FILING DATE		

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U.S. PATENT DOCUMENTS

*EXAMINER

DOCUMENT

INITIAL		NO.	DATE	NAME	CLASS	CLASS	DATE
	AA						
	AB						-
	·		FOREIGN	PATENT DOCUMENTS			741014701

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSI YES	NO
AC							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
Se	AD	European Search Report and Annex of Application No. EP 03 25 7126 dated July 20, 2005.		
Sh	AE	Partial European Search Report and Annex of Application No. EP 03 25 7126 dated May 9, 2005.		

EXAMINER	Cal l	DATE CONSIDERED 2/27/06
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*EXAMINER: Initial if docu	ment considered, whether or not	citation is in conformance with MPEP 609; Draw line through
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